

Day : Thursday
Date: 6/14/2007

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Time: 13:59:29

Inventor Name Search Result

Your Search was:

Last Name = MIZUTANI

First Name = MASAKI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>07638575</u>	5218880	150	01/08/1991	JOINT BETWEEN TRANSMISSION AND ITS GEAR CONTROL MECHANISM OF REMOTE CONTROL TYPE	MIZUTANI, MASAKI
<u>08818179</u>	5981864	150	03/14/1997	PHOTOVOLTAIC ELEMENT ARRAY AND METHOD OF FABRICATING THE SAME	MIZUTANI, MASAKI
<u>09050110</u>	5979263	150	03/30/1998	SHIFT LEVER DEVICE	MIZUTANI, MASAKI
<u>09297980</u>	6333206	150	05/12/1999	PROCESS FOR THE PRODUCTION OF SEMICONDUCTOR DEVICE	MIZUTANI, MASAKI
<u>09332949</u>	6200830	150	06/15/1999	FABRICATION PROCESS OF A SEMICONDUCTOR DEVICE	MIZUTANI, MASAKI
* <u>09333019</u> Review	6258666	150	06/15/1999	METHOD OF PRODUCING SEMICONDUCTOR THIN FILM AND METHOD OF PRODUCING SOLAR CELL USING SAME	MIZUTANI, MASAKI
<u>09346678</u>	Not Issued	161	07/02/1999	CRYSTAL GROWTH PROCESS, SEMICONDUCTOR DEVICE, AND ITS PRODUCTION PROCESS	MIZUTANI, MASAKI
<u>09656014</u>	6682990	150	09/07/2000	SEPARATION METHOD OF SEMICONDUCTOR LAYER AND PRODUCTION METHOD OF SOLAR CELL	MIZUTANI, MASAKI
* <u>09813137</u> Review	6802926	150	03/21/2001	METHOD OF PRODUCING SEMICONDUCTOR THIN FILM AND METHOD OF PRODUCING SOLAR CELL USING SAME	MIZUTANI, MASAKI
<u>09851564</u>	6620862	150	05/08/2001	SHEET RESIN COMPOSITION	MIZUTANI,

					MASAKI
<u>09964332</u>	<u>6551908</u>	150	09/28/2001	METHOD FOR PRODUCING SEMICONDUCTOR THIN FILMS ON MOVING SUBSTRATES	MIZUTANI, MASAKI
<u>09978633</u>	<u>6953506</u>	150	10/18/2001	WAFER CASSETTE, AND LIQUID-PHASE GROWTH SYSTEM AND LIQUID-PHASE GROWTH PROCESS WHICH MAKE USE OF THE SAME	MIZUTANI, MASAKI
<u>10014418</u>	<u>7022181</u>	150	12/14/2001	LIQUID PHASE GROWTH PROCESS, LIQUID PHASE GROWTH SYSTEM AND SUBSTRATE MEMBER PRODUCTION METHOD	MIZUTANI, MASAKI
<u>10022545</u>	<u>6802900</u>	150	12/20/2001	LIQUID PHASE GROWTH METHODS AND LIQUID PHASE GROWTH APPARATUS	MIZUTANI, MASAKI
<u>10229123</u>	<u>6824609</u>	150	08/28/2002	LIQUID PHASE GROWTH METHOD AND LIQUID PHASE GROWTH APPARATUS	MIZUTANI, MASAKI
<u>10259285</u>	Not Issued	161	09/30/2002	Crystal growth process, semiconductor device, and its production process	MIZUTANI, MASAKI
<u>10364517</u>	<u>6951584</u>	150	02/12/2003	APPARATUS FOR PRODUCING SEMICONDUCTOR THIN FILMS ON MOVING SUBSTRATES	MIZUTANI, MASAKI
<u>10385457</u>	<u>7014711</u>	150	03/12/2003	LIQUID-PHASE GROWTH APPARATUS AND METHOD	MIZUTANI, MASAKI
<u>10400636</u>	<u>6872248</u>	150	03/28/2003	LIQUID-PHASE GROWTH PROCESS AND LIQUID-PHASE GROWTH APPARATUS	MIZUTANI, MASAKI
<u>10427610</u>	<u>6884695</u>	150	04/30/2003	SHEET RESIN COMPOSITION AND PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE THEREWITH	MIZUTANI, MASAKI
<u>10505979</u>	<u>7175706</u>	150	08/27/2004	PROCESS OF PRODUCING MULTICRYSTALLINE SILICON SUBSTRATE AND SOLAR CELL	MIZUTANI, MASAKI
<u>10530189</u>	Not Issued	25	02/03/2006	Polycrystalline silicon substrate	MIZUTANI, MASAKI
<u>10563115</u>	Not	30	01/03/2006	Silicon layer production method	MIZUTANI,

Applicants' Invention

	Issued			and solar cell production method	MASAKI
<u>10665075</u>	7048797	150	09/22/2003	LIQUID-PHASE GROWTH PROCESS AND LIQUID-PHASE GROWTH APPARATUS	MIZUTANI, MASAKI
<u>10670301</u>	Not Issued	161	09/26/2003	Method for growing silicon film, method for manufacturing solar cell, semiconductor substrate, and solar cell	MIZUTANI, MASAKI
* <u>10676094</u>	7118625 <i>Review?</i>	150	10/02/2003	LIQUID PHASE GROWTH METHOD FOR SILICON CRYSTAL, MANUFACTURING METHOD FOR SOLAR CELL AND LIQUID PHASE GROWTH APPARATUS FOR SILICON CRYSTAL	MIZUTANI, MASAKI
<u>10678855</u>	7060339	150	10/03/2003	DICING/DIE-BONDING FILM, METHOD OF FIXING CHIPPED WORK AND SEMICONDUCTOR DEVICE	MIZUTANI, MASAKI
<u>10722175</u>	Not Issued	161	11/25/2003	Adhesives composition, adhesive film, and semiconductor apparatus using the same	MIZUTANI, MASAKI
<u>10849414</u>	Not Issued	41	05/19/2004	Dicing die-bonding film, method of fixing chipped work and semiconductor device	MIZUTANI, MASAKI
<u>11082112</u>	Not Issued	41	03/16/2005	Dicing die-bonding film	MIZUTANI, MASAKI
<u>11270562</u>	Not Issued	71	11/10/2005	Liquid-phase growth apparatus and method	MIZUTANI, MASAKI
<u>11369931</u>	Not Issued	30	03/07/2006	Dicing/die-bonding film, method of fixing chipped work and semiconductor device	MIZUTANI, MASAKI
<u>11392574</u>	Not Issued	25	03/30/2006	Gas sensor element, method for manufacturing the same, and gas sensor	MIZUTANI, MASAKI
<u>11580661</u>	Not Issued	25	10/13/2006	Gas sensing device and gas sensor	MIZUTANI, MASAKI
<u>11642507</u>	Not Issued	30	12/20/2006	Connector and connector assembly	MIZUTANI, MASAKI
<u>11671982</u>	Not Issued	25	02/06/2007	DICING DIE-BONDING FILM, METHOD OF FIXING CHIPPED WORK AND SEMICONDUCTOR DEVICE	MIZUTANI, MASAKI

Inventor Search Completed: No Records to Display.

Day : Thursday
Date: 6/14/2007

Time: 13:59:53

 **PALM INTRANET****Inventor Name Search Result**

Your Search was:

Last Name = NISHIDA

First Name = SHOJI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>06382708</u>	<u>4456304</u>	150	05/27/1982	SHIELD TUNNELING MACHINE AND EARTH REMOVING APPARATUS THEREFOR	NISHIDA, SHOJI
<u>07354716</u>	<u>5002796</u>	150	05/22/1989	PROCESS FOR FORMING FUNCTIONAL ZINC OXIDE FILMS USING ALKYL ZINC COMPOUND AND OXYGEN- CONTAINING GAS	NISHIDA, SHOJI
<u>07355642</u>	Not Issued	166	05/23/1989	PROCESS FOR THE FORMATION OF A SILICON- CONTAINING SEMICONDUCTOR THIN FILM BY CHEMICALLY REACTING ACTIVE HYDROGEN ATOMS WITH LIQUEFIED FILM- FORMING RAW MATERIAL GAS ON THE SURFACE OF A SUBSTRATE	NISHIDA, SHOJI
<u>07425350</u>	<u>4927786</u>	150	10/20/1989	PROCESS FOR THE FORMATION OF A SILICON- CONTAINING SEMICONDUCTOR THIN FILM BY CHEMICALLY REACTING ACTIVE HYDROGEN ATOMS WITH LIQUEFIED FILM- FORMING RAW MATERIAL GAS ON THE SURFACE OF A SUBSTRATE	NISHIDA, SHOJI
<u>07537818</u>	<u>5098850</u>	150	06/14/1990	PROCESS FOR PRODUCING SUBSTRATE FOR SELECTIVE CRYSTAL GROWTH, SELECTIVE CRYSTAL GROWTH PROCESS AND PROCESS FOR PRODUCING	NISHIDA, SHOJI

				SOLAR BATTERY BY USE OF THEM	
<u>07623526</u>	<u>5103851</u>	150	12/07/1990	SOLAR BATTERY AND METHOD OF MANUFACTURING THE SAME	NISHIDA, SHOJI
<u>07794462</u>	<u>5254481</u>	250	11/19/1991	POLYCRYSTALLINE SOLAR CELL MANUFACTURING METHOD	NISHIDA, SHOJI
<u>07837976</u>	<u>5279686</u>	250	02/20/1992	SOLAR CELL AND METHOD FOR PRODUCING THE SAME	NISHIDA, SHOJI
<u>07887821</u>	<u>5269852</u>	250	05/26/1992	CRYSTALLINE SOLAR CELL AND METHOD FOR PRODUCING THE SAME	NISHIDA, SHOJI
<u>07915693</u>	Not Issued	166	07/27/1992	PROCESS FOR PRODUCING A THIN SILICON SOLAR CELL	NISHIDA, SHOJI
<u>07920497</u>	Not Issued	166	09/28/1992	PROCESS FOR PRODUCING A SOLAR CELL BY MEANS OF EPITAXIAL GROWTH PROCESS	NISHIDA, SHOJI
<u>08010627</u>	Not Issued	166	01/28/1993	A SEMICONDUCTOR DEVICE SUBSTRATE BY BONDING A POROUS LAYER AND AN AMORPHOUS LAYER	NISHIDA, SHOJI
<u>08190584</u>	<u>5403771</u>	250	02/02/1994	PROCESS FOR PRODUCING A SOLAR CELL BY MEANS OF EPITAXIAL GROWTH PROCESS	NISHIDA, SHOJI
<u>08262381</u>	<u>5403751</u>	250	06/20/1994	PROCESS FOR PRODUCING A THIN SILICON SOLAR CELL	NISHIDA, SHOJI
<u>08284265</u>	Not Issued	166	08/02/1994	METHOD FOR PRODUCING SEMICONDUCTOR DEVICE SUBSTRATE BY BONDING A POROUS LAYER AND AN AMORPHOUS LAYER	NISHIDA, SHOJI
<u>08352034</u>	<u>5575862</u>	250	11/30/1994	POLYCRYSTALLINE SILICON PHOTOELECTRIC CONVERSION DEVICE AND PROCESS FOR ITS PRODUCTION	NISHIDA, SHOJI
<u>08369325</u>	<u>5492859</u>	150	01/06/1995	METHOD FOR PRODUCING SEMICONDUCTOR DEVICE SUBSTRATE BY BONDING A POROUS LAYER AND AN AMORPHOUS LAYER	NISHIDA, SHOJI
<u>08406157</u>	<u>5584941</u>	150	03/17/1995	SOLAR CELL AND	NISHIDA, SHOJI

				PRODUCTION PROCESS THEREFOR	
<u>08932708</u>	<u>6387780</u>	150	09/18/1997	FABRICATION PROCESS OF SOLAR CELL	NISHIDA, SHOJI
<u>08993034</u>	<u>6100166</u>	150	12/18/1997	PROCESS FOR PRODUCING SEMICONDUCTOR ARTICLE	NISHIDA, SHOJI
<u>08999132</u>	<u>6190937</u>	150	12/29/1997	METHOD OF PRODUCING SEMICONDUCTOR MEMBER AND METHOD OF PRODUCING SOLAR CELL	NISHIDA, SHOJI
<u>09046600</u>	<u>6258698</u>	150	03/24/1998	PROCESS FOR PRODUCING SEMICONDUCTOR SUBSTRATE	NISHIDA, SHOJI
<u>09047325</u>	<u>6211038</u>	150	03/25/1998	SEMICONDUCTOR DEVICE, AND METHOD FOR MANUFACTURING THE SAME	NISHIDA, SHOJI
<u>09198263</u>	<u>6429035</u>	150	11/24/1998	METHOD OF GROWING SILICON CRYSTAL IN LIQUID PHASE AND METHOD OF PRODUCING SOLAR CELL	NISHIDA, SHOJI
<u>09200867</u>	<u>6231667</u>	150	11/27/1998	LIQUID PHASE GROWTH METHOD AND LIQUID PHASE GROWTH APPARATUS	NISHIDA, SHOJI
<u>09208377</u>	<u>6391108</u> <i>Review!</i>	150	12/10/1998	LIQUID PHASE GROWTH METHOD OF SILICON CRYSTAL, METHOD OF PRODUCING SOLAR CELL, AND LIQUID PHASE GROWTH APPARATUS	NISHIDA, SHOJI
<u>09310953</u>	<u>6248948</u>	150	05/13/1999	SOLAR CELL MODULE AND METHOD OF PRODUCING THE SAME	NISHIDA, SHOJI
<u>09310954</u>	<u>6331208</u> <i>Review!</i>	150	05/13/1999	PROCESS FOR PRODUCING SOLAR CELL, PROCESS FOR PRODUCING THIN-FILM SEMICONDUCTOR, PROCESS FOR SEPARATING THIN-FILM SEMICONDUCTOR, AND PROCESS FOR FORMING SEMICONDUCTOR	NISHIDA, SHOJI
<u>09346678</u>	Not Issued	161	07/02/1999	CRYSTAL GROWTH PROCESS, SEMICONDUCTOR DEVICE, AND ITS PRODUCTION PROCESS	NISHIDA, SHOJI
<u>09401775</u>	<u>6391743</u>	150	09/22/1999	METHOD AND APPARATUS	NISHIDA, SHOJI

				FOR PRODUCING PHOTOELECTRIC CONVERSION DEVICE	
<u>09572940</u>	<u>6534336</u>	150	05/18/2000	PRODUCTION METHOD OF PHOTOELECTRIC CONVERSION DEVICE, AND PHOTOELECTRIC CONVERSION DEVICE PRODUCED BY THE METHOD	NISHIDA, SHOJI
<u>09586887</u>	<u>6664169</u>	150	06/05/2000	PROCESS FOR PRODUCING SEMICONDUCTOR MEMBER, PROCESS FOR PRODUCING SOLAR CELL, AND ANODIZING APPARATUS	NISHIDA, SHOJI
<u>09592559</u>	<u>6448155</u>	150	06/12/2000	PRODUCTION METHOD OF SEMICONDUCTOR BASE MATERIAL AND PRODUCTION METHOD OF SOLAR CELL	NISHIDA, SHOJI
<u>09634542</u>	<u>6534382</u>	150	08/08/2000	PROCESS FOR PRODUCING SEMICONDUCTOR ARTICLE	NISHIDA, SHOJI
<u>09638398</u>	<u>6756289</u>	150	08/15/2000	METHOD OF PRODUCING SEMICONDUCTOR MEMBER AND METHOD OF PRODUCING SOLAR CELL	NISHIDA, SHOJI
<u>09656014</u>	<u>6682990</u>	150	09/07/2000	SEPARATION METHOD OF SEMICONDUCTOR LAYER AND PRODUCTION METHOD OF SOLAR CELL	NISHIDA, SHOJI
<u>09662604</u>	<u>6500731</u>	150	09/14/2000	PROCESS FOR PRODUCING SEMICONDUCTOR DEVICE MODULE	NISHIDA, SHOJI
<u>09664340</u>	<u>6566277</u>	150	09/18/2000	LIQUID-PHASE GROWTH METHOD, LIQUID-PHASE GROWTH APPARATUS, AND SOLAR CELL	NISHIDA, SHOJI
<u>09764400</u>	Not Issued	161	01/19/2001	Semiconductor device, and method for manufacturing the same	NISHIDA, SHOJI
<u>09769329</u>	<u>6602767</u>	150	01/26/2001	METHOD FOR TRANSFERRING POROUS LAYER, METHOD FOR MAKING SEMICONDUCTOR DEVICES, AND METHOD FOR MAKING SOLAR BATTERY	NISHIDA, SHOJI
<u>09790589</u>	<u>6384313</u>	150	02/23/2001	Solar cell module and method of	NISHIDA, SHOJI

				producing the same	
<u>09819680</u>	<u>6566235</u>	150	03/29/2001	PROCESS FOR PRODUCING SEMICONDUCTOR MEMBER, AND PROCESS FOR PRODUCING SOLAR CELL	NISHIDA, SHOJI
<u>09927406</u>	Not Issued	161	08/13/2001	Fabrication process of solar cell	NISHIDA, SHOJI
<u>09964332</u>	<u>6551908</u>	150	09/28/2001	METHOD FOR PRODUCING SEMICONDUCTOR THIN FILMS ON MOVING SUBSTRATES	NISHIDA, SHOJI
<u>09978633</u>	<u>6953506</u>	150	10/18/2001	WAFER CASSETTE, AND LIQUID-PHASE GROWTH SYSTEM AND LIQUID-PHASE GROWTH PROCESS WHICH MAKE USE OF THE SAME	NISHIDA, SHOJI
<u>10014418</u>	<u>7022181</u>	150	12/14/2001	LIQUID PHASE GROWTH PROCESS, LIQUID PHASE GROWTH SYSTEM AND SUBSTRATE MEMBER PRODUCTION METHOD	NISHIDA, SHOJI
<u>10022545</u>	<u>6802900</u>	150	12/20/2001	LIQUID PHASE GROWTH METHODS AND LIQUID PHASE GROWTH APPARATUS	NISHIDA, SHOJI
<u>10083585</u>	<u>6720237</u>	150	02/27/2002	METHOD FOR MANUFACTURING A SEMICONDUCTOR FILM	NISHIDA, SHOJI
<u>10120357</u>	Not Issued	161	04/12/2002	Liquid phase growth method of silicon crystal, method of producing solar cell, and liquid phase growth apparatus	NISHIDA, SHOJI
<u>10229123</u>	<u>6824609</u>	150	08/28/2002	LIQUID PHASE GROWTH METHOD AND LIQUID PHASE GROWTH APPARATUS	NISHIDA, SHOJI

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Day : Thursday
Date : 6/14/2007


PALM INTRANET

Time: 14:00:24

Inventor Name Search Result

Your Search was:

Last Name = NAKAGAWA

First Name = KATSUMI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>06105778</u>	Not Issued	161	12/20/1979	FILM FORMING PROCESS UTILIZING GLOW DISCHARGE	NAKAGAWA, KATSUMI
<u>06131497</u>	<u>4464043</u>	150	03/18/1980	AUTOMATIC PRINTING APPARATUS	NAKAGAWA, KATSUMI
<u>06199266</u>	Not Issued	161	10/21/1980	IMAGE FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06214045</u>	<u>4451547</u>	150	12/08/1980	ELECTROPHOTOGRAPHIC ALPHA-SI(H) MEMBER AND PROCESS FOR PRODUCTION THEREOF	NAKAGAWA, KATSUMI
<u>06269846</u>	<u>4461819</u>	150	06/03/1981	IMAGE-FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06367024</u>	Not Issued	166	04/09/1982	IMAGE FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06412076</u>	<u>4404076</u>	150	08/27/1982	FILM FORMING PROCESS UTILIZING DISCHARGE	NAKAGAWA, KATSUMI
<u>06418293</u>	<u>4565731</u>	150	09/15/1982	IMAGE-FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06423808</u>	Not Issued	1	09/15/1982	IMAGE-FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06438910</u>	Not Issued	166	11/03/1982	SEMICONDUCTOR ELEMENT	NAKAGAWA, KATSUMI
<u>06449842</u>	Not Issued	166	12/15/1982	ELECTROPHOTOGRAPHIC PHOTSENSITIVE MEMBER AND PROCESS FOR PRODUCTION THEREOF	NAKAGAWA, KATSUMI
<u>06453158</u>	Not	166	12/27/1982	SEMICONDUCTOR ELEMENT	NAKAGAWA,

	Issued				KATSUMI
<u>06456716</u>	Not Issued	166	01/10/1983	SEMICONDUCTOR ELEMENT	NAKAGAWA, KATSUMI
<u>06456717</u>	4625224	150	01/10/1983	THIN FILM TRANSISTOR HAVING POLYCRYSTALLINE SILICON LAYER WITH 0.01 TO 5 ATOMIC % CHLORINE	NAKAGAWA, KATSUMI
<u>06492633</u>	Not Issued	166	05/09/1983	THIN FILM TRANSISTOR	NAKAGAWA, KATSUMI
<u>06494049</u>	Not Issued	166	05/12/1983	SEMICONDUCTOR ELEMENT	NAKAGAWA, KATSUMI
<u>06505270</u>	4558357	150	06/17/1983	COLOR IMAGE READING METHOD AND APPARATUS	NAKAGAWA, KATSUMI
<u>06511029</u>	4500864	150	07/05/1983	PRESSURE SENSOR	NAKAGAWA, KATSUMI
<u>06561161</u>	Not Issued	166	12/14/1983	IMAGE-FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06565146</u>	4551405	150	12/23/1983	IMAGE-FORMING PROCESS EMPLOYING MEMBER WITH A DEPLETION LAYER	NAKAGAWA, KATSUMI
<u>06565191</u>	4557990	150	12/23/1983	HYDROGENATED AMORPHOUS SILICON PHOTOSENSITIVE MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06571147</u>	Not Issued	166	01/17/1984	IMAGE FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06581435</u>	4507375	150	02/17/1984	ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MEMBER AND PROCESS FOR PRODUCTION THEREOF	NAKAGAWA, KATSUMI
<u>06586972</u>	4658280	150	03/07/1984	AMORPHOUS SILICON PHOTODIODE OF LAYERS HAVING DIFFERING CONDUCTIVITY	NAKAGAWA, KATSUMI
<u>06621630</u>	4667214	150	06/18/1984	PHOTOSENSOR	NAKAGAWA, KATSUMI
<u>06647869</u>	Not Issued	166	09/05/1984	IMAGE FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06673155</u>	Not Issued	166	11/19/1984	METHOD FOR DRIVING A MATRIX CIRCUIT	NAKAGAWA, KATSUMI
<u>06695428</u>	4552824	150	01/28/1985	ELECTRO PHOTOGRAPHIC	NAKAGAWA,

				PHOTOSENSITIVE MEMBER AND PROCESS FOR PRODUCTION THEREOF	KATSUMI
<u>06712027</u>	Not Issued	166	03/15/1985	LED ARRAY AND PARTITIVE DRIVING METHOD THEREFOR	NAKAGAWA, KATSUMI
<u>06716508</u>	Not Issued	166	03/25/1985	SEMICONDUCTOR ELEMENT	NAKAGAWA, KATSUMI
<u>06719445</u>	Not Issued	166	04/03/1985	IMAGE-FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06721651</u>	Not Issued	166	04/10/1985	PHOTOELECTRIC CONVERSION APPARATUS	NAKAGAWA, KATSUMI
<u>06749117</u>	Not Issued	166	06/26/1985	IMAGE FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06753578</u>	Not Issued	166	07/10/1985	IMAGE READOUT APPARATUS	NAKAGAWA, KATSUMI
<u>06755797</u>	4680644	150	07/17/1985	METHOD AND APPARATUS FOR READING AN IMAGE	NAKAGAWA, KATSUMI
<u>06757670</u>	Not Issued	168	07/22/1985	MATRIX CIRCUIT	NAKAGAWA, KATSUMI
<u>06763214</u>	4613558	150	08/07/1985	HYDROGENATED AMORPHOUS SILICON PHOTOSENSITIVE METHOD FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
<u>06770085</u>	Not Issued	166	08/28/1985	LINE SENSOR FOR COLOR READING AND COLOR IMAGE READING DEVICE	NAKAGAWA, KATSUMI
<u>06782098</u>	Not Issued	166	09/30/1985	ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MEMBER AND PROCESS FOR PRODUCTION THEREOF	NAKAGAWA, KATSUMI
<u>06790155</u>	4664998	150	10/22/1985	ELECTROPHOTOGRAPHIC IMAGE FORMING MEMBER HAVING HYDROGENATED AMORPHOUS PHOTOCONDUCTIVE LAYER INCLUDING CARBON	NAKAGAWA, KATSUMI
<u>06815113</u>	4719501	150	12/26/1985	SEMICONDUCTOR DEVICE HAVING JUNCTION FORMED FROM TWO DIFFERENT HYDROGENATED POLYCRYSTALLINE SILICON LAYERS	NAKAGAWA, KATSUMI

06840975	Not Issued	166	03/13/1986	IMAGE FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
06842270	4742239	150	03/21/1986	LINE PHOTODSENSOR WITH CROSSTALK SUPPRESSION	NAKAGAWA, KATSUMI
06846480	Not Issued	166	03/31/1986	SEMICONDUCTOR ELEMENT	NAKAGAWA, KATSUMI
06849442	Not Issued	166	04/08/1986	PHOTOELECTRIC CONVERSION APPARATUS	NAKAGAWA, KATSUMI
06850526	4737653	150	04/11/1986	IMAGE SENSOR WITH AUXILIARY LIGHT SOURCE	NAKAGAWA, KATSUMI
06872935	4670369	150	06/11/1986	IMAGE-FORMING MEMBER FOR ELECTROPHOTOGRAPHY	NAKAGAWA, KATSUMI
06885336	4766477	150	07/11/1986	A SEMICONDUCTOR DEVICE INCLUDING A SEMICONDUCTOR LAYER HAVING A POLYCRYSTALLINE SILICON FILM WITH SELECTED ATOMIC CONSTITUENCY	NAKAGAWA, KATSUMI
06902087	Not Issued	166	08/27/1986	MATRIX CIRCUIT	NAKAGAWA, KATSUMI
06908883	Not Issued	166	09/15/1986	LINE SENSOR FOR COLOR READING AND COLOR IMAGE READING DEVICE	NAKAGAWA, KATSUMI

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